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03500.017672. PATENT APPLICATION

OIPE JC139 JUL 14 2004 PATENT & TRADEMARK OFFICE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: NYA
TAKU SHIMODA ET AL.	)	
	:	Group Art Unit: 2878
Application No.: 10/685,420	)	
	:	
Filed: October 16, 2003	)	
	:	
For: SURFACE CONDUCTION ELECTRON-EMITTING DEVICE AND MANUFACTURING METHOD OF IMAGE-FORMING APPARATUS	) :	July 13, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed Form PTO-1449.

For the concise statement of relevance of non-English documents 7-326311 and 9-050757, the Examiner is respectfully referred to the English abstracts attached thereto.

For the concise explanation of relevance for non-English document JP 9-102271, the Examiner is respectfully referred to U.S. Patent No. 6,296,896 attached thereto.

For the concise explanation of relevance for non-English document JP 2000-251665, the Examiner is respectfully referred to EP 0 936 652 A1 attached thereto.

For the concise explanation of relevance for non-English document JP 8-185818, the Examiner is respectfully referred to U.S. Patent No. 6,137,218 attached thereto.

For the concise explanation of relevance for non-English document JP 6-342636, the Examiner is respectfully referred to U.S. Patent No. 5,659,329 attached thereto.

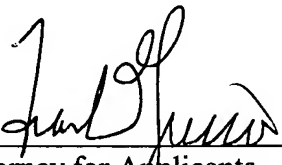
No English abstract of listed document JP 64-31332 is presently available.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by

telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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FORM PTO 1449 (*modified*)

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

LIST OF REFERENCES CITED BY APPLICANT(S)
(*Use several sheets if necessary*)

Date Submitted to PTO: [DATE]

ATTY DOCKET NO.	APPLICATION NO.
03500.017672.	10/685,420

APPLICANT: TAKU SHIMODA, ET AL.

FILING DATE	GROUP
October 16, 2003	2872

IPE JC139 JUL 16 2004 PATENT & TRADEMARK OFFICE

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		6,586,155 B2	07/03	Furuse et al.	430	270.1	
		2003-0026959A1	02/06	Furuse et al.	428	195	4/16/02
		6,296,896 B1	10/01	Takahashi et al.	427	77	
		6,137,218	10/00	Kaneko et al.	313	495	
		5,659,329	08/97	Yamanobe et al.	345	74	
		2004-0022933 A1	02/04	Tomida et al.	427	78	
		2003-0062816	4/03	Terada et al.	313	310	

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	JP	9-102271	04/97	Japan			U.S. Patent No. 6,296,896
	JP	2000-251665	09/00	Japan			EP 936652
	EP	0 936 652 A1	08/99	Europe			English
	JP	64-31332	02/89	Japan			No Abstract
	JP	7-326311	12/95	Japan			Abstract
	JP	8-185818	07/96	Japan			U.S. 6,137,218
	JP	9-050757	02/97	Japan			Abstract
	JP	6-342636	12/94	Japan			U.S. 5,659,329

OTHER DOCUMENT(S) (*Including Author, Title, Date, Pertinent Pages, Etc.*)

		M. Hartwell, et al., "Strong Electron Emission From Patterned Tin-Indium Oxide Thin Films", Technical Digest, 1975 International Electron Devices Meeting, pp. 519-521

EXAMINER	DATE CONSIDERED

*EXAMINER: *Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.*